

Fee only



Application No. 09/295,607
Docket No. 740756-1961

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	
)	Confirmation No. 7371
Shunpei YAMAZAKI et al.)	
)	Examiner: Steven Ho Yin Loke
Serial No. 09/295,607)	
)	Group Art Unit: 2811
Filed: April 22, 1999)	
)	Date: October 26, 2004
For: SEMICONDUCTOR DEVICE HAVING)	
ALUMINUM NITRIDE FILM)	

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
U.S. Patent and Trademark Office
220 20th Street, South
Customer Window, Mail Stop Patent Applications
Crystal Plaza Two, Lobby, Room 1B03
Arlington, Virginia 22202

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

Applicants cite JP-02-121369; JP-59-117164 and JP-58-016566 which were cited in the counterpart Japanese patent application and mailed September 7, 2004.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner-initialed copy of this form be returned to the undersigned.

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